



DOCKET NUMBER: 198322US2CONT/sbj

RECEIVED

#8
CFR
RAB
9/7/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE-5

IN RE APPLICATION OF:
Takahiro HORIKOSHI, et al.

: GROUP: 2851 MAIL ROOM

SERIAL NUMBER: 09/680,513

: ATTENTION:
Application Division
Customer Corrections

FILED: October 6, 2000

FOR: EXPOSURE METHOD, EXPOSURE APPARATUS AND MAKING METHOD OF
THE APPARATUS, AND DEVICE AND MANUFACTURING METHOD OF THE
DEVICE

SECOND REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

The Patent Office is requested to provide a corrected Official Filing Receipt for the attached. If you have any questions, please do not hesitate to contact us.

No fees are required. However, in the event that a fee is required, please charge the appropriate amount to our Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Marvin J. Spivak
Attorney of Record
Registration Number 24,913

Joseph A. Scafetta, Jr.
Registration No. 26,803



22850

Tel. (703) 413-3000
Fax. (703) 413-2220
(OSMMN 10/98)



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
www.uspto.gov

APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO.	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/680,513	10/06/2000	2851	2164	198322USCONT	9	58	11

CONFIRMATION NO. 9594

CORRECTED FILING RECEIPT



OC000000006076798

22850
OBLON SPIVAK MCCLELLAND MAIER & NEUSTADT PC
FOURTH FLOOR
1755 JEFFERSON DAVIS HIGHWAY
ARLINGTON, VA 22202

Date Mailed: 05/15/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Takahiro Horikoshi, Tokyo, JAPAN;
Takahisa Kikuchi, Tokyo, JAPAN;
Masahiro Nei, Kanagawa-ken, JAPAN;

Domestic Priority data as claimed by applicant

Foreign Applications

JAPAN 10-111406 04/07/1998
JAPAN 10-125272 04/20/1998

If Required, Foreign Filing License Granted 12/11/2000

Projected Publication Date: N/A

Non-Publication Request: No

Early Publication Request: No

Title

Exposure method, exposure apparatus and making method of the apparatus, and device and manufacturing method of the device

RECEIVED
SEP - 6 2001
NOON

MAY 17 2001

OBLON, SPIVAK, McCLELLAND
MAIER & NEUSTADT, P.C.

Preliminary Class
355

Data entry by : SMALLWOOD, EAON

Team : 1600

Date: 05/15/2001



PLEASE NOTE THAT THE CONTINUING DATA INFORMATION WAS OMITTED. IT SHOULD READ AS FOLLOWS:

THIS IS A 371 OF PCT/JP99/01802 04/06/1999

PLEASE NOTE THAT THE 3RD APPLICANT'S INFORMATION IS INCORRECT. IT SHOULD READ AS FOLLOWS:

- 1) TAKAHIRO HORIKOSHI, TOKYO, JAPAN
- 2) TAKAHISA KIKUCHI, TOKYO, JAPAN
- 3) MASAHIRO NEI, **YOKOHAMA-SHI**, JAPAN

100011110011
SEP-6 1999
100011110011